



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasuhiro OMURA

Group Art Unit: 2882

Application No.: 10/587,254

Examiner: C. KREUTZER

Filed: June 1, 2007

Docket No.: 128834

For: OPTICAL SYSTEM, EXPOSURE SYSTEM, AND EXPOSURE METHOD

**AMENDMENT FILED WITH RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the May 27, 2011 Notice of Allowance, and upon entry of the attached  
Request for Continued Examination, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims;

**Remarks.**